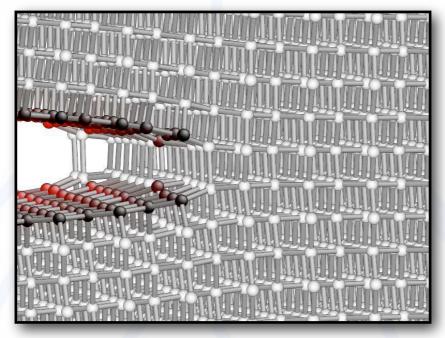
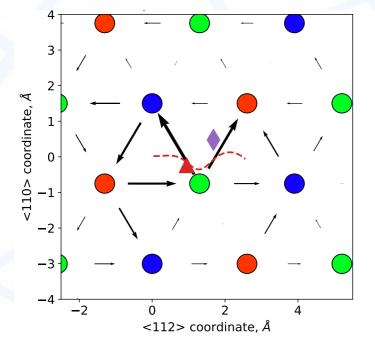
# **Complex chemistry & realistic systems...**

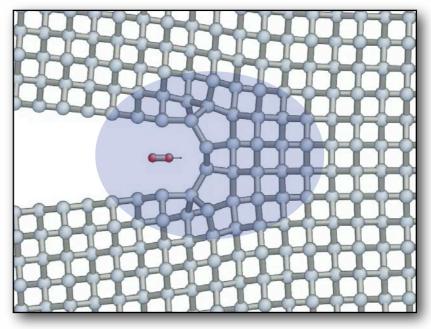
... require large systems, long timescales and quantification of uncertainty



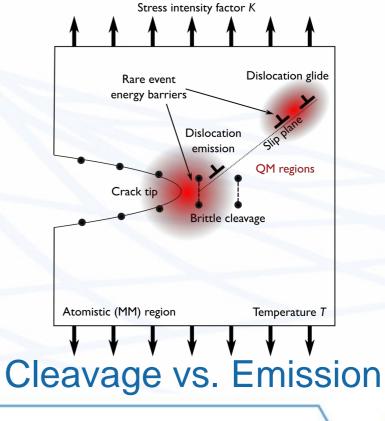
**Three Dimensional Systems** 



#### **Dislocation/impurity interaction**



### **Stress Corrosion Cracking**



## **General-purpose machine learning potential for silicon**

Gaussian Approximation Potential (GAP) framework – data-driven Gaussian Process model, trained from DFT data via SOAP representation of atomic environments (~2.5k configs, ~170k atomic environments, sparsified to 9k)

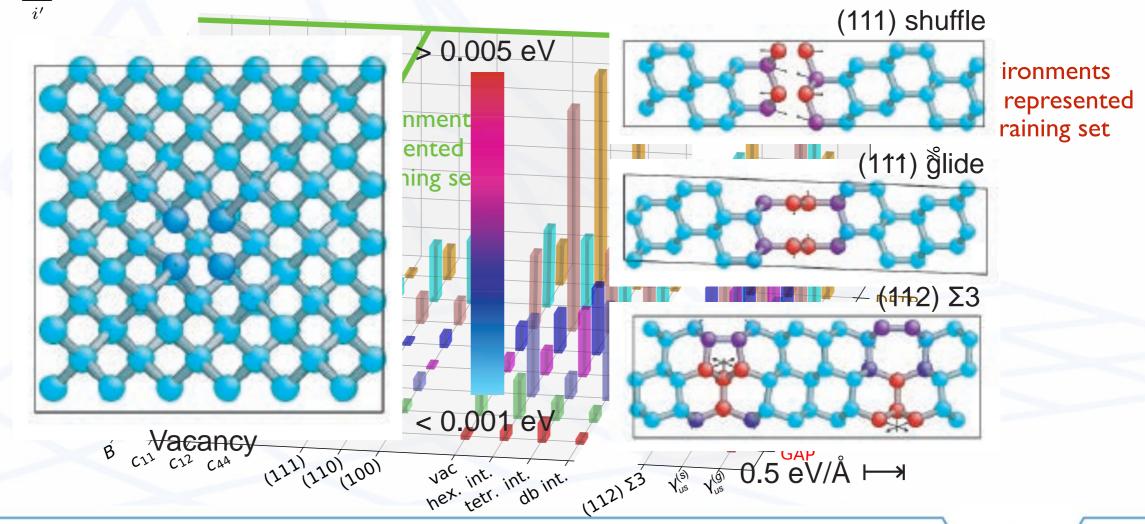
$$E = \sum_{i < j} V^{(2)}(r_{ij}) + \sum_{i} \sum_{s}^{m} \alpha_{s} K(\mathcal{R}_{i}, \mathcal{R}_{s}), \qquad \alpha =$$

$$\tilde{K}(\mathcal{R}_{i}, \mathcal{R}_{j}) = \int_{\hat{R} \in SO_{3}} d\hat{R} \left| \int d\mathbf{r} \rho_{i}(\mathbf{r}) \rho_{j}(\hat{R}\mathbf{r}) \right|^{2} \qquad \begin{array}{l} \text{Post} \\ \text{of pot} \\ \text{of pot} \\ K \end{array}$$

$$\rho_{i}(\mathbf{r}) = \sum_{i'} f_{\text{cut}}(r_{ii'}) e^{-(\mathbf{r} - \mathbf{r}_{ii'})/2\sigma_{\text{atom}}^{2}} \qquad K$$

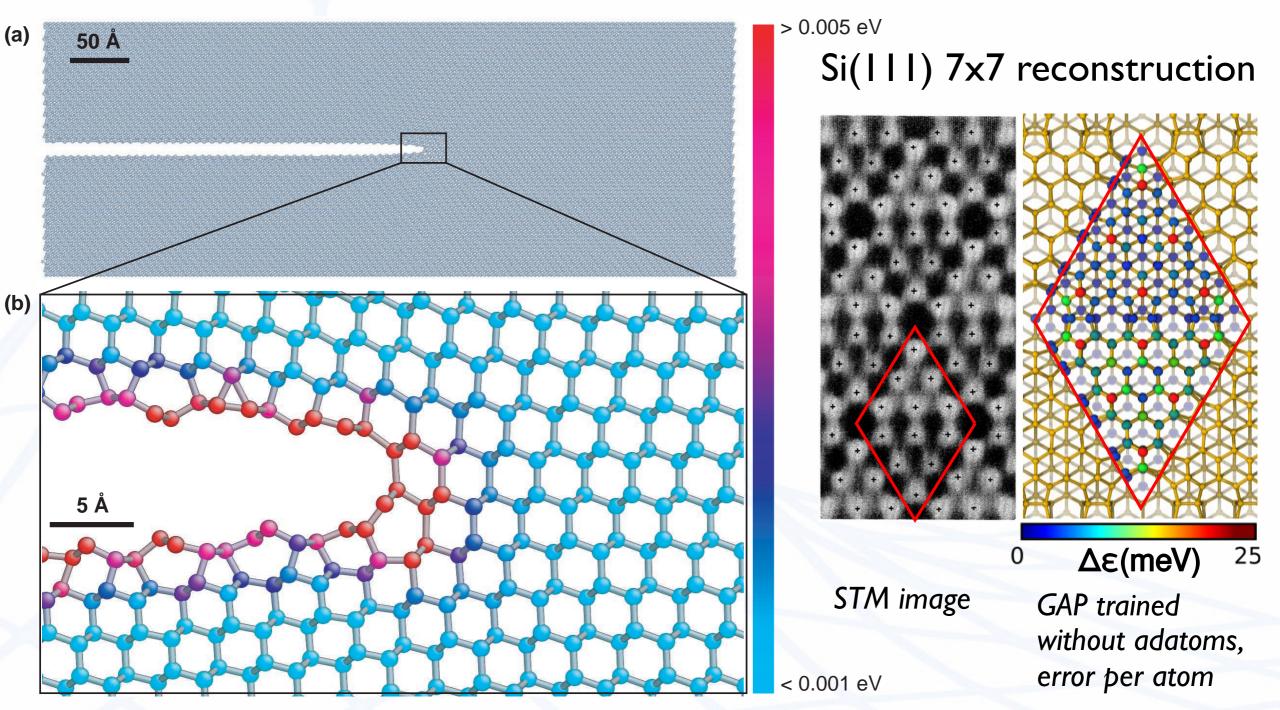
$$\boldsymbol{lpha} = \left[ \mathbf{K}_{MM} + \mathbf{K}_{MN} \mathbf{L} \boldsymbol{\Lambda}^{-1} \mathbf{L}^{\mathrm{T}} \mathbf{K}_{NM} \right]^{-1} \mathbf{K}_{MN} \mathbf{L} \boldsymbol{\Lambda}^{-1} \boldsymbol{y},$$

Posterior variance (over an effective ensemble of potentials trained on same data) is analytic:  $K(\mathcal{R}_i, \mathcal{R}_i) - \mathbf{k}^T (\mathbf{K}_{MM} + \sigma_e \mathbf{I})^{-1} \mathbf{k}$ 



A. P. Bartok et al. *Science Advances* **3**, e1701816 (2017) A. P. Bartok, JRK, N. Bernstein and G. Csanyi, PRX **8**, 041048 (2018)

## **Uncertainty Quantification for the Silicon GAP model**



Gaussian Approximation Potential (GAP) for silicon – data-driven model, with per-atom predicted errors from variance of posterior probability distribution

A. P. Bartok et al. *Science Advances* **3**, e1701816 (2017) A. P. Bartok, JRK, N. Bernstein and G. Csanyi, PRX **8**, 041048 (2018)